



Image 173.
52201-0605

IN THE UNITED STATES AND PATENT AND TRADEMARK OFFICE

Applicant : Tatsuhiro Sato et al.
Serial No. : 09/935,334
Filed : August 22, 2001
For : QUARTZ GLASS BODY HAVING IMPROVED
RESISTANCE AGAINST PLASMA CORROSION,
AND METHOD FOR PRODUCTION THEREOF
Group art unit : 1731
Examiner : Carlos N. Lopez

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail
in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on: October 22, 2003

Andrew L. Tiajloff
Name of Applicant, Assignee
or Registered Representative

Andrew L. Tiajloff
Signature

October 22, 2003
Date of Signature

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE AND AMENDMENT

Sir:

Applicant responds as follows to the restriction requirement dated September 24, 2003 in
the above application.

Election

Applicant elects Group I, claims 1 to 15.

Amendment

Please amend the application as follows: